

# Frequency-dependent conductivity of granular metals

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We explore the frequency-dependent conductivity,  $\sigma$ , of granular metals (GMs). Granular metal comprise nanoscale metal islands embedded in a dielectric matrix. We target the metal volume fraction,  $\phi$ , so that the few-nm diameter metal islands are separated by a  $\sim 1$  nm dielectric barrier. These metal/insulator composites can be modelled as a complex resistor-capacitor network with complementary tunneling and capacitive conduction paths [1]. At low frequencies, ideal GMs are highly insulating with thermally-assisted tunneling between islands occurring at high E-fields. At high frequencies, capacitive transport dominates; conductivity increases orders of magnitude.

We compare M-SiN<sub>x</sub> and M-YSZ (M = Mo or Co; YSZ = yttria-stabilized-zirconia) GM thin films grown via rf co-sputtering on sapphire. Frequency-dependent conductivity is evaluated using impedance spectroscopy at ambient and cryogenic temperatures. Temperature and field-dependent DC conductivity provide insight into tunneling mechanisms. Granular metal structure (Fig. 1a, b) and composition are determined by scanning transmission electron microscopy (STEM) and x-ray photoemission spectroscopy (XPS).

Through careful selection of the metal-insulator system and synthesis optimization, we prepared GM films having  $\sigma_{\text{MHz}}/\sigma_{\text{DC}} > 10^5$  (Fig. 1c). This  $\sigma_{\text{MHz}}/\sigma_{\text{DC}}$  ratio was achieved for Mo-SiN<sub>x</sub> using depositions conditions that significantly reduced the vacancies present in the sputtered insulator. Analysis of metal/insulator interfaces via XPS showed metal-oxide formation in M-YSZ and metal-silicide formation in M-SiN<sub>x</sub> [2]. Control of deposition conditions can minimize these defects, allowing  $\sigma_{\text{MHz}}/\sigma_{\text{DC}}$  optimization for high-pass filters.

This work was supported by the Laboratory Directed Research and Development program at Sandia National Laboratories (SNL). SNL is managed and operated by NTESS under DOE NNSA contract DE-NA0003525. SAND2022-12964 A.

[1] H. Bakkali *et al.* Sci Rep **6**, 29676 (2016)

[2] S. Gilbert *et al.* J. Phys.: Condens. Matter **34** 204007 (2022)

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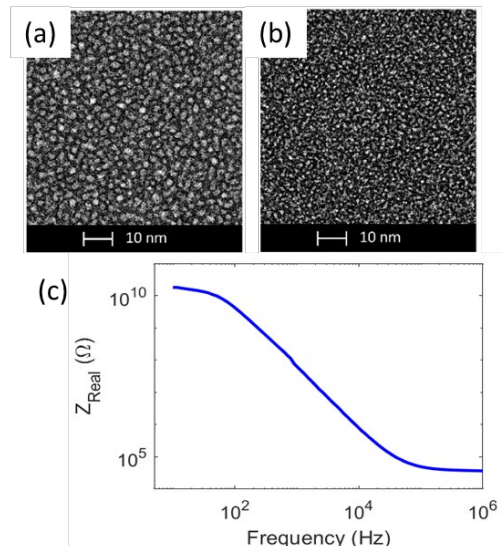


Figure 1: STEM of (a) Co-SiN<sub>x</sub> and (b) Mo-SiN<sub>x</sub>. In (c), complex impedance of Mo-SiN<sub>x</sub>.



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**Dr. Laura Biedermann**  
Principal Member of the Technical Staff  
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Date: September 23, 2022

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Principal Member of the Technical Staff  
Electronic, Optical, and Nano Materials Department  
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Hi Heather,

Thank you very much for your prompt reply and advice. I will submit the abstract and send Yvonne an e-mail letting her know that I cannot accept the copyright.

Thank you very much for your help!

Laura

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**From:** Heather Korff <[Heather@avs.org](mailto:Heather@avs.org)>  
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Hi All,

Others have had this issue. Please submit but then send Yvonne Towse (cc'd above) an email saying that you cannot accept the copyright on the submitted abstract and she will keep that in our records. Della (also cc'd) has advised we aren't doing any recording.

I hope this helps.

Regards,

Heather

\*\*\*\*\*

*Heather Korff*

Heather Korff

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